

Application/Control No.	Applicant(s)/Patent under Reexamination	
10/710,763	LIN, JOANNA	
Examiner	Art Unit	
Long Nauven	2816	

	SEARCHED					
Class	Subclass	Date	Examiner			
327	170,112	10/12/05	LN			
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INTERFERENCE SEARCHED					
Class	Subclass	Date	Examiner		
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(See	print	omt).			

SEARCH NOTES (INCLUDING SEARCH STRATEGY)				
	DATE	EXMR		
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. East Text Search (see print ont)	10/13/05	LN		
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